

Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L1	382 hsg	USPAT	1999/11/11 15:24			0
2	BRS	L2	44400 1100	USPAT	1999/11/11 15:25			0
3	BRS	L3	9557 1???	USPAT	1999/11/11 15:26	Truncation Overflow. Return string from Server is: 5`0`1?		
4	BRS	L4	276828 1900	USPAT	1999/11/11 15:28			0
5	BRS	L5	74247 1090	USPAT	1999/11/11 15:27			0
6	BRS	L6	33114 1095	USPAT	1999/11/11 15:28			0
7	BRS	L7	61037 1905	USPAT	1999/11/11 15:29			0
8	BRS	L8	5221 (4 5 6 7) adj2 (degree degrees c centigrade centegrade celsius)	USPAT	1999/11/11 15:34			0
9	BRS	L9	329813 substrate substrates wafer wafers	USPAT	1999/11/11 15:35			0
10	BRS	L10	1717 8 and 9	USPAT	1999/11/11 15:36			0
11	BRS	L11	77903 sin or si adj n si.sub? nitride	USPAT	1999/11/11 15:38			0
12	BRS	L12	19 8 near6 11 and 9	USPAT	1999/11/11 15:45			0
13	BRS	L13	8043 (plasma plasmas) same 11	USPAT	1999/11/11 15:46			0
14	BRS	L14	22 (plasma plasmas) same 11 same 8	USPAT	1999/11/11 15:46			0

L #	Hits	Search Text	DBs	Time Stamp
1	L1	1522 plasma same remot\$	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 08:57
2	L2	101926 (silicon adj nitride) or sin or (si adj2 3 adj2 n)	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:05
3	L3	241 1 and 2	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:09
4	L4	121770 wafer or substrate	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:10
5	L5	33665 2 same 4	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:12
6	L6	153 5 and 1	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:18
7	L7	336767 4 heat\$ or temperature	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:50
8	L8	270647 7 same 4	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:54
9	L9	17 rpecvd	USPAT; USOCR; EPO; JPO; Derwent	1999/11/11 09:54